**Amendments to the Claims:** 

This listing of claims will replace all prior versions, and listings, of claims in the

application:

**Listing of Claims:** 

1. (Currently Amended) A dielectric material for forming a structure of an integrated circuit,

said dielectric material comprising:

a plurality of fluorinated carbon nanostructures; and

a copolymer layer binding said fluorinated carbon nanostructures to define the dielectric

material.

2. (Cancelled)

3. (Previously Presented) The dielectric material of claim 1 wherein said fluorinated carbon

nanostructures comprise a plurality of fluorinated carbon nanotubes.

4. (Original) The dielectric material of claim 1 wherein said dielectric material has a dielectric

constant of less than about 3.

5. (Original) The dielectric material of claim 1 wherein said structure further comprises at least

one conductive feature disposed in said dielectric material.

6. (Previously Presented) The dielectric material of claim 1 wherein said fluorinated carbon

nanostructures comprise a plurality of fluorinated carbon buckyballs.

Page 3 of 9 Serial No. 10/711,764 Amendment and Response dated July 12, 2006

Reply to Office Action of April 13, 2006 IBM Docket BUR920040152US1 7. (Original) The dielectric material of claim 1 further comprising a cap layer on said dielectric

material.

8. (Currently Amended) The dielectric material of claim 7 wherein said fluorinated carbon

nanostructures, said copolymer layer, and said cap layer have an effective dielectric constant of

less than about 3.

9. (Cancelled)

10. (Currently Amended) The dielectric material of claim [[7]] 1 wherein said fluorinated

carbon nanostructures and said copolymer layer have an effective dielectric constant of less than

about 3.

11. (Currently Amended) A semiconductor structure formed on a substrate, comprising:

a dielectric layer comprising a plurality of fluorinated carbon nanostructures and a

copolymer layer binding said fluorinated carbon nanostructures; and

at least one conductive feature in said dielectric layer, said conductive feature electrically

isolated from nearby conductive features by portions of said dielectric layer.

12. (Original) The semiconductor structure of claim 11 wherein said dielectric layer has an

exposed surface, and further comprising:

a cap layer of an insulating material at least partially covering said exposed surface, said

cap layer having a top surface, and said conductive feature having a top surface substantially

coplanar with said top surface of said cap layer.

13. (Cancelled)

14. (Previously Presented) The semiconductor structure of claim 11 wherein said fluorinated

carbon nanostructures comprise a plurality of fluorinated carbon nanotubes.

15. (Original) The semiconductor structure of claim 11 wherein said dielectric layer has a

dielectric constant of less than about 3.

16. (Original) The semiconductor structure of claim 11 wherein said structure comprises a

plurality of conductors electrically isolated by said layer of said dielectric material.

17. (Previously Presented) The semiconductor structure of claim 11 wherein said fluorinated

carbon nanostructures comprise a plurality of fluorinated carbon buckyballs.

18. (Previously Presented) The semiconductor structure of claim 11 further comprising:

a cap layer disposed on said fluorinated carbon nanostructures.

19. (Currently Amended) The semiconductor structure of claim 18 wherein said fluorinated

carbon nanostructures, said copolymer layer, and said cap layer collectively have a dielectric

constant of less than about 3.

20. (Original) The semiconductor structure of claim 11 further comprising:

a substrate selected from the group consisting of an interconnect level, a dielectric

material, a buried barrier layer, a metallization line, and a semiconductor wafer.

21. (Original) An integrated circuit comprising a plurality of circuit elements and the

semiconductor structure of claim 11, said conductive feature being electrically coupled with at

least one of said circuit elements.

Page 5 of 9 Serial No. 10/711,764

Amendment and Response dated July 12, 2006 Reply to Office Action of April 13, 2006

## 22. (Cancelled)

23. (Currently Amended) The dielectric material of claim [[22]] 11 wherein said fluorinated carbon nanostructures and said copolymer layer have an effective dielectric constant of less than about 3.

## 24-45. (Cancelled)

46. (New) A semiconductor structure formed on a substrate, comprising:

a dielectric layer comprising a plurality of fluorinated carbon nanostructures, said dielectric layer having a dielectric constant of less than about 3; and

at least one conductive feature in said dielectric layer, said conductive feature electrically isolated from nearby conductive features by portions of said dielectric layer.

47. (New) A semiconductor structure formed on a substrate, comprising:

a dielectric layer comprising a plurality of fluorinated carbon nanostructures;

a cap layer disposed on said fluorinated carbon nanostructures, said fluorinated carbon nanostructures and said cap layer collectively having a dielectric constant of less than about 3; and

at least one conductive feature in said dielectric layer, said conductive feature electrically isolated from nearby conductive features by portions of said dielectric layer.